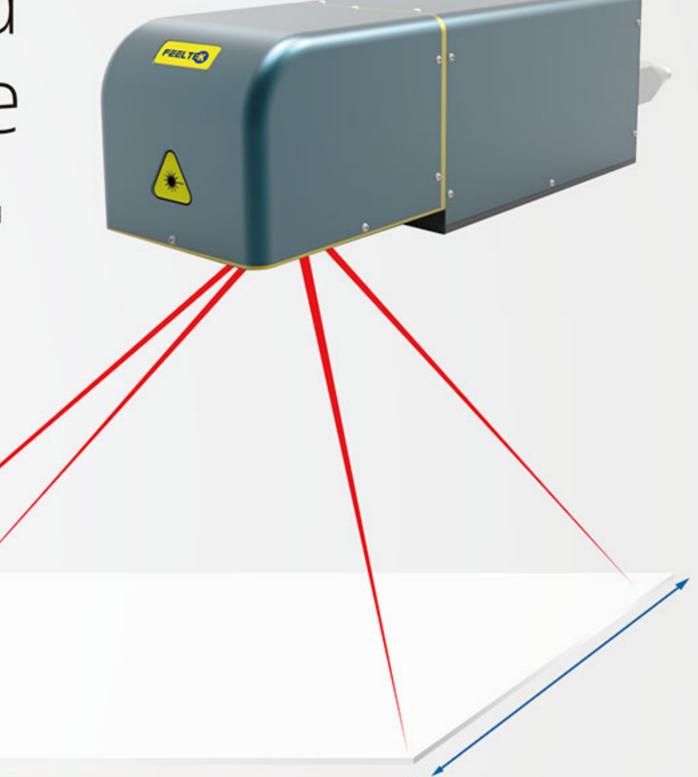
High-end industry application

Larger work field Smaller spot size

- Automatic focal adjust option for choose, finish work field and focal length switch through software.
- Support high power components customization, max. power up to 6KW.
- The optional off-axis CCD module, applicated in positioning marking in moving line.
- The optical adjuster could solve the common difficulty of adjustment from QCS interface optical offset. Once adjusted, accurate to the central point.

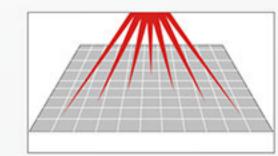




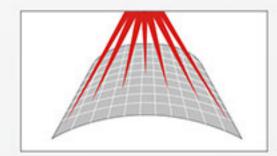
### 1200x1200mm

# Flexible large field processing

Through the 3rd axis control to reach larger work field.



Achieve 1200\*1200mm work field



Smaller spot size Achieve 400\*400\*20 mm curved surface application, minimum spot size 0.028mm

### **3D Surface Processing**

The FR30-F applies dynamic focus control technology, breaks the limitation of traditional marking, and can do no distortion marking in the large-scale surface, 3D surface, steps, cone surface, slope surface and other objects.

	Regular Scanhead	FR30-F			
Cylinder surface	Can not cover focal points at two edges, distorted edge marking effect	VS	+++++		
Different steps	+ + + + + + + + +  Can not cover focal points on two different heights, no average marking	VS	++++++		
Cone surface	Can not cover focal points on the cone, distorted marking effect	VS	* + + + *		
Slope surface	+ + + + +  Can not cover focal points on the slope, distorted marking effect	VS	+++++		

## **Application Highlight**



- Large field marking
- Scribing
- Precision Mould
- Surface treatment

Additive Manufacturing

Curved surface moving

line application







FEELTEN

Large field marking

3D application

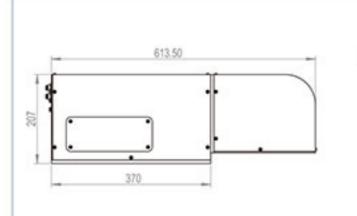
360°rotation marking

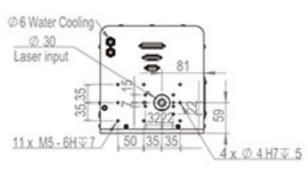
#### **Product Technical Information**

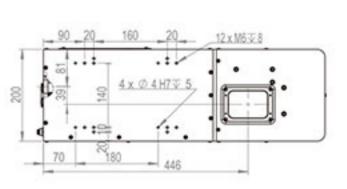
	Technical Info.	Specific	ations		
Items	Output Voltage(VDC)	±24	4		
	Current(A)	10A			
	Protocol	XY2-100 Protocol			
	Weight (KG)	17			
	Size(mm)	613.5*200	13.5*200*242.5		
Optical Specifications	Aperture Size(mm)	30			
	Input beam diameter(mm)	8.5			
Galvanometer Specifications	Product line	Pro	P2		
	Scan Angle(°)	±11	±11		
	Repeatability(µrad)	8	5		
	Max.Gain Drift(ppm/k)	100	50		
	Max.Offset Drift(µrad/k)	30	15		
	Long-term drift over 8h(mrad)	≤0.2	≤0.1		
	Tracking Error(ms)	≤0.44	≤0.44		
	Max.processing speed(characters/s)	350@400×400	350@400×400		

#### **Curved surface Version**

Working Field & Spot Diameter	Working Field(mm)	400×400×20	500×500×50	600×600x80	800×800×120	1000×1000×200	1200x1200x200
	The Min.Spot Diameter@1/e2(mm)	0.028	0.032	0.039	0.049	0.064	Customized version
	Focal length(mm)	480	600	720	960	1200	
arge Field Vers	ion						
Working Field & Spot Diameter	Working Field(mm)	800×800	10	000×1000	1200×12	00 Abov	/e 1200x1200
	The Min.Spot Diameter@1/e2(mm)	0.049		0.064	0.077	C	ustomized
	Focal length(mm)	960		1200	1440		version







1440

1200

